



S/N 10/081,818

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al. Examiner: Tu-Tu V. Ho
Serial No.: 10/081,818 Group Art Unit: 2818
Filed: February 20, 2002 Docket No.: 1303.045US1
Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL TUNNEL BARRIER INTERPOLY INSULATORS

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
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Alexandria, VA 22313-1450

This responds to the Office Action mailed on April 29, 2005. Please amend the above-identified patent application as follows.